

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chan-Yong Park
 Appl. No. : 10/802,593
 Filed : March 17, 2004
 For : PHOTO-DIODE HAVING A
 HIGH CHARGE DENSITY
 PORTION IN A FIELD
 CONTROLLING LAYER AND
 METHOD FOR FABRICATING
 THE SAME (as amended)
 Examiner : Thomas L. Dickey
 Group Art Unit : 2826

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all
 marked attachments are being deposited with
 the United States Postal Service as first-class
 mail in an envelope addressed to:
 Commissioner for Patents, P.O. Box 1450,
 Alexandria, VA 22313-1450, on

September 19, 2005

(Date)

Mincheol Kim, Reg. No. 51,306

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed March 18, 2005 in the above-identified
 application. Applicant submits the following items for consideration in connection with the
 application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3
 of this paper.

Remarks/Arguments begin on page 9 of this paper.

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01 FC:2202

75.00 OP

09/23/2005 SHASSEN1 00000039 10802593

02 FC:2253

510.00 OP